


<b>Search Notes</b>  	<b>Application/Control No.</b>  10709500	<b>Applicant(s)/Patent Under Reexamination</b>  KAPOLKA ET AL.
	<b>Examiner</b>  Mejia, Anthony	<b>Art Unit</b>  2109

SEARCHED			
Class	Subclass	Date	Examiner

SEARCH NOTES		
Search Notes	Date	Examiner
EAST Limited Text Based Search (See Search History)	8/22/07	Mejia, Anthony
EAST Inventor and Assignee Searched (See Search History)	8/22/07	Mejia, Anthony
EAST Text Based Search (See Search History)	8/22/07	Mejia, Anthony
PLUS Search (See Search History)	8/22/07	Mejia, Anthony
NPL Search at ACM <a href="http://portal.acm.org/dl.cfm">http://portal.acm.org/dl.cfm</a>	8/20/07	Mejia, Anthony
NPL Search at IEEE <a href="http://ieeexplore.ieee.org/Xplore/dynhome.jsp">http://ieeexplore.ieee.org/Xplore/dynhome.jsp</a> (See Search History)	8/20/07	Mejia, Anthony

INTERFERENCE SEARCH			
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